

Notice of References Cited	Application/Control No. 10/022,728	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Kevin M Bernatz	Art Unit 1773	Page 1 of 1

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	B	US-5,480,733	01-1996	Okumura et al.	428/694T
	C	US-6,010,795	01-2000	Chen et al.	428/611
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	N	WO98-16923	04-1998	PCT	Chen et al.	
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